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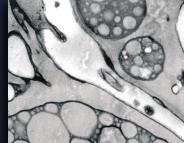
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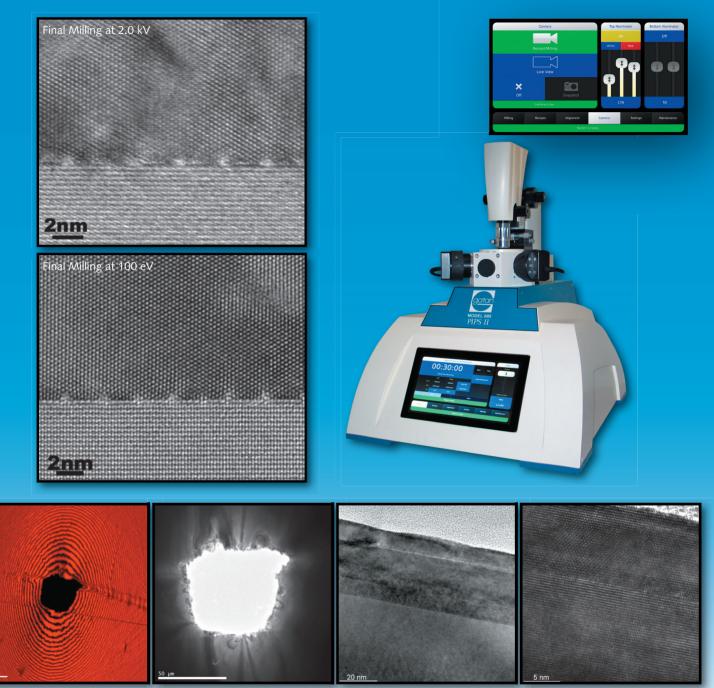
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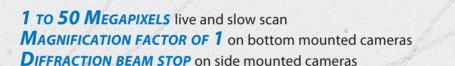
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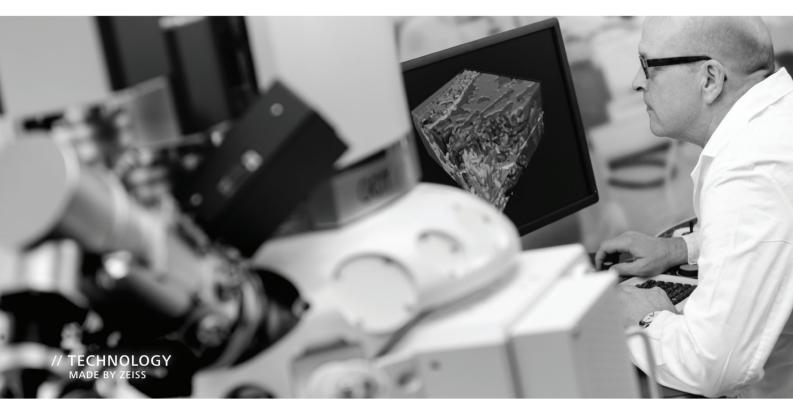
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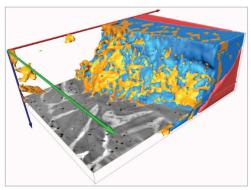
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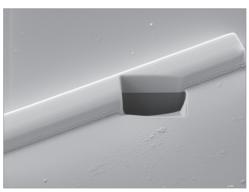


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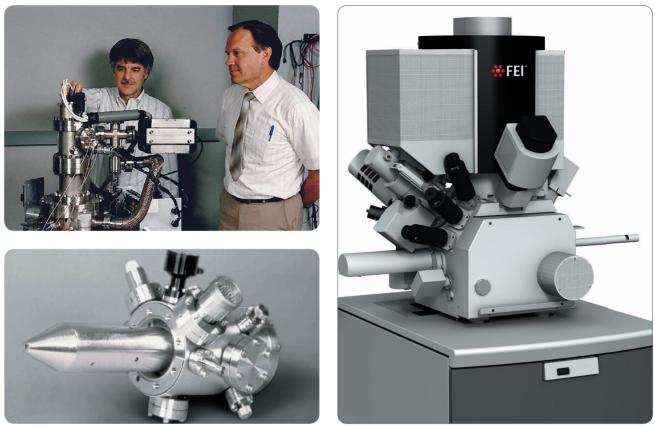


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(Top left) Dave Tuggle and FEI founder Lyn Swanson working on an early edition FIB column. (Bottom left) A two-lens Schottky column. (Right) Helios NanoLab 660.

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Lynwood Swanson, the founder of FEI, was selected to receive the 2014 Pittcon Heritage Award. A pioneer in commercial electron microscopy, Swanson has enabled researchers around the world to explore the unseen.



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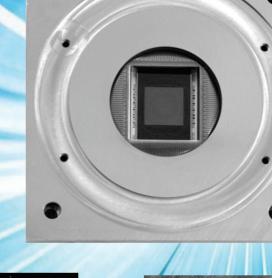
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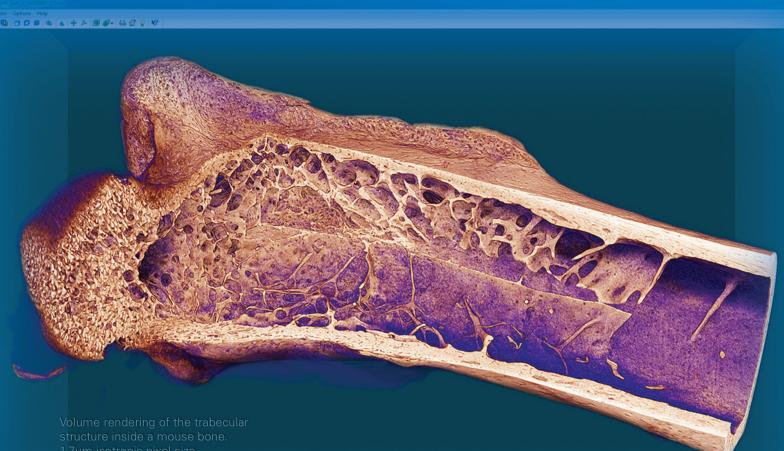
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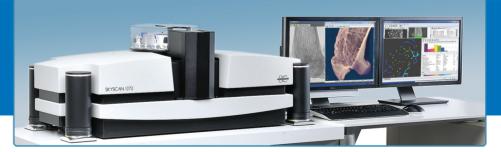






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